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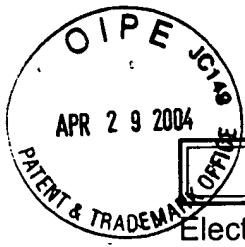
Electronic Patent Application Submission

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EFS ID: 60114
Application ID: 10647925 
Title of Invention: High-Voltage Transistor With Buried Conduction Layer
First Named Inventor: Donald Disney
Domestic/Foreign Application: Domestic Application
Filing Date: 2003-08-26
Effective Receipt Date: 2004-04-29
Submission Type: Information Disclosure Statement
Filing Type:
Confirmation number: 2438
Attorney Docket Number: 03692.P054D2

Total Fees Authorized:

Digital Certificate Holder: cn=Bradley John Bereznak,ou=Registered Attorneys,ou=Patent and Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US
Certificate Message Digest: 6ebf4406b0db5b64cdb51e4a5cd4814b1d404787



TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	High-Voltage Transistor With Buried Conduction Layer	
Application Number:	10/647925	
Date:	2003-08-26	
First Named Applicant:	Donald Ray Disney	
Confirmation Number:	2438	
Attorney Docket Number:	03692.P054D2	
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Submitted by:	Elec. Sign.	Sign. Capacity
Bradley J. Bereznak Registered Number: 33,474	BBJ	Attorney
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Comments		



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	High-Voltage Transistor With Buried Conduction Layer									
Application Number:	10/647925 									
Confirmation Number:	2438									
First Named Applicant:	Donald Disney									
Attorney Docket Number:	03692.P054D2									
Art Unit:	2811									
Examiner:	Steven Ho Yin Loke									
Search string:	(5146298 or 5155574 or 6184555 or 6168983 or 6207994 or 4618541 or 4665426 or 4890146 or 4922327 or 5386136 or 5894154 or 4626879 or 4754310 or 4764800 or 4811075 or 4926074 or 4963951 or 5010024 or 5025296 or 5040045 or 5068700 or 5237193 or 5258636 or 5270264 or 4939951 or 4967246 or 5313082 or 5637898 or 5654206 or 5656543 or 5659201 or 5663599 or 5716887 or 5324683 or 5349225 or 5359221 or 5411901 or 5521105 or 5550405 or 5670828 or 5679608 or 5943959 or 6010926 or 5998833).pn.									
US Patent Documents										
Note: Applicant is not required to submit a paper copy of cited US Patent Documents										
init	Cite.No.	Patent No.	Date	Patentee	Kind					
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Signature

APP_ID=10647925	Examiner Name	Date
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